

#9 GP2863

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yasunori INOUE et al.

Serial No.: 09/228,148

Group Art Unit: 2812

Filed: January 11, 1999

Examiner: Unassigned

For: SEMICONDUCTOR DEVICE INCLUDING AN INSULATION FILM ON A CONDUCTIVE LAYER AND MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Director of Patents and Trademarks
Washington, D.C. 20231

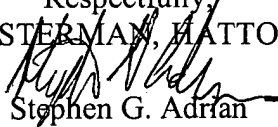
July 7, 2000

Sir:

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were made of record in related copending application Serial Nos. 09/429,698 and 09/037,674. These copending applications are directed to technically related subject matter as the above-identified application.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully,
ARMSTRONG, WESTERMAN, HATTORI, McLELAND & NAUGHTON


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